

Attorney Docket No.: 033082M300



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Confirmation No.: 1005

Applicants : Yasuo KOBAYASHI, et al.
U.S. Serial No. : 10/568,461
Filed : February 15, 2006
Examiner : Reema PATEL
Group Art Unit : 2812
For : SEMICONDUCTOR DEVICE, METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE
AND GAS FOR PLASMA CVD

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed on March 30, 2007, please amend the above-identified application as set forth below and consider the following remarks.

This Amendment is accompanied by a Petition for Extension of Time (Three Months) and a deposit account payment for the sum of \$1170, in payment of the extension fee (\$1020) and for the addition of three dependent claims (\$150).

10/01/2007 JADD01 00000005 024300 10568461
02 FC:1202 150.00 DA